

PATENT
Docket No. 150.00810102IN THE UNITED STATES PATENT AND TRADEMARK OFFICE#7 / SUPP
DS
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Rstohr

Applicant(s): Vaartstra) Group Art Unit: 2823
Serial No.: 09/865,612) Examiner: G. Fourson III
Filed: May 25, 2001)
For: METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-
CONTAINING FILMS ON SEMICONDUCTOR STRUCTURES

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT RECEIVEDAssistant Commissioner for Patents
Washington D.C. 20231

FEB 28 2003

TECHNOLOGY CENTER 2800

Sir:

In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with C.F.R. §§ 1.97 *et. seq.*, the materials enclosed herewith are brought to the attention of the Examiner as possibly being of interest in connection with the above-identified patent application. Per M.P.E.P. § 609, the information cited in the present Information Disclosure Statement shall not be construed to be an admission that the information is, or is considered to be, material to patentability. Consideration of each of the documents listed on the attached 1449 form(s) is respectfully requested. Pursuant to the provisions of M.P.E.P. §609, Applicant further requests that a copy of the 1449 form(s), marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

Since this Information Disclosure Statement is submitted after the receipt of an Office Action in the above-identified patent application, please charge Deposit Account No. 13-4895 in the amount of \$180 under 37 C.F.R. §§1.97(c) and 1.17(p), any additional fees, or credit any overpayment.

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Supplemental Information Disclosure Statement

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METHODS, COMPLEXES, AND SYSTEMS FOR FORMING METAL-CONTAINING FILMS ON
SEMICONDUCTOR STRUCTURES

The Examiner is invited to contact Applicant's' Representatives at the below-listed telephone number, if they can be of any assistance during prosecution of the present application.

CERTIFICATE UNDER 37 C.F.R. 1.8:

The undersigned hereby certifies that this paper is being transmitted by facsimile in accordance with 37 CFR §1.6(d) to the Patent and Trademark Office, addressed to Assistant Commissioner for Patents, Washington, D.C. 20231, on this 28 day of February, 2003, at 1:20 pm (Central Time)

February 28, 2003

Date

Respectfully submitted,

Vaartstra

By his Representatives,

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